

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1792
Yonhua Tzeng) Examiner: Stouffer, Kelly M.
Serial No.: 10/772,740)
Filed: February 5, 2004) **AMENDMENT AND RESPONSE TO**
For: **METHOD OF PLASMA**) **OFFICE ACTION MAILED**
ENHANCED CHEMICAL VAPOR) **December 21, 2007**
DEPOSITION OF DIAMOND)
USING METHANOL-BASED) 162 North Wolfe Road
SOLUTIONS) Sunnyvale, California 94086
) (408) 530-9700
) Customer No.: 28960

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENTS

Sir:

Please amend the subject application as follows:

Remarks/Arguments begin on page 2 of this paper.